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OFGS File No. P/1071-1504

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent application of:

Hidefumi NAKATA

Date: March 4, 2002

Serial No.: 09/989,962

Group Art Unit: ----

Filed: February 26, 1999

Examiner: -----

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ORIGINALLY FILED

For: **MIM CAPACITOR AND MANUFACTURING METHOD THEREFOR**

Assistant Commissioner for Patents  
Washington, DC 20231

Attention: Official Draftsperson

FORMAL DRAWINGS

Sir:

Enclosed herewith please find three (3) sheets of formal drawings containing Figures 1-4D for the above-identified application.

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to: Assistant Commissioner for Patents, Washington, D.C. 20231, on March 4, 2002:

Respectfully submitted,

Martin Pfeffer

Name of applicant, assignee or  
Registered Representative

Signature

March 4, 2002

Date of Signature

Martin Pfeffer

Registration No.: 20,808

OSTROLENK, FABER, GERB & SOFFEN, LLP

1180 Avenue of the Americas

New York, New York 10036-8403

Telephone: (212) 382-0700

MP:jy  
Enclosures